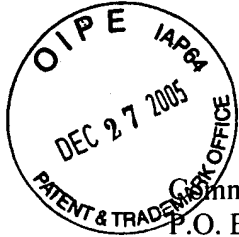


**S/N 09/471,460**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Thomas A. Figura et al.	Examiner:	Calvin Lee
Serial No.:	09/471,460	Group Art Unit:	2818
Filed:	December 22, 1999	Docket:	303.932US4
Title:	USE OF A PLASMA SOURCE TO FORM A LAYER DURING THE FORMATION OF A SEMICONDUCTOR DEVICE		



**REVOCATION AND POWER OF ATTORNEY**  
**CERTIFICATE UNDER 37 CFR § 3.73(b)**  
**AND CHANGE OF CORRESPONDENCE ADDRESS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with 37 C.F.R. Section 1.36, M.P.E.P. Section 402.05 and 402.07, please revoke any existing Powers of Attorney, if any, and appoint the following attorneys and/or patent agents to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith:

**Customer Number: 21186**

**CERTIFICATE UNDER 37 CFR § 3.73(b)**

Micron Technology, Inc. hereby certifies that it is the assignee of the entire right, title and interest in the patent application identified above by virtue of an assignment from the inventor in the parent application filed June 2, 1995 and recorded on Reel 7551, Frames 0829-0832. To the best of my knowledge and belief, title is in Micron Technology, Inc., the assignee.

Pursuant to 37 C.F.R. §3.73(b) I hereby declare that I, Michael Lynch, am empowered to sign this certificate on behalf of Micron Technology, Inc., the assignee.

I hereby declare that all statements made herein of my own knowledge are true, and that all statements made on information and belief are believed to be true.

Please direct all correspondence in this case to:

Schwegman, Lundberg, Woessner & Kluth, P.A.  
P.O. Box 2938  
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Telephone No. (612) 373-6900  
Customer No. 21186

Date Dec 7, 2005

By [Signature]

Michael Lynch

A person authorized to execute this document on  
behalf of Micron Technology, Inc.